30. (Original) The method of claim 1, wherein the substrate comprises a metallic material, a semiconductor material, a ceramic, or a polymer.

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- 31. (Original) The method of claim 30, wherein the substrate comprises a coating comprising a metallic material, a semiconductor material, a ceramic, a glass, or a polymer.
- 32. (Original) The method of claim 1, further comprising disposing a material on the substrate before the step of placing.
- 33. (Currently Amended) The method of claim 1, wherein the stamp comprises a lumen having a portal providing communication between the lumen and an exterior of the stamp, stamp; wherein the step of disposing comprises placing the substrate within the lumen; and wherein the step of modulating comprises reducing the cross sectional dimension of the lumen.
- 34. (Original) The method of claim 33, wherein walls of the stamp defining the lumen are characterized by flat, curved, or a combination of both.
- 35. (Previously Presented) The method of claim 33, wherein the stamp is tubular.
- 36. (Original) The method of claim 33, wherein the stamp has a diameter of at least 100 micrometers.
- 37. (Original) The method of claim 1, wherein the stamp and the substrate have the same or different shapes.

38-115. (Canceled).

116. (Currently Amended) A method of patterning a surface, comprising: providing a stamp having a stamping surface; disposing a substrate proximate to the stamping surface; and

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modulating the dimensions of the stamp to place the stamping surface in contact with the substrate to produce a pattern on the stamping surface of the substrate,

wherein the stamp comprises a first lumen having a portal providing communication between the first lumen and an exterior of the stamp;

wherein the step of disposing comprises placing the substrate within the first lumen; and

wherein the step of modulating comprises reducing a cross sectional dimension of the first lumen.

- 117. (Previously Presented) The method of claim 116, wherein the first lumen has two portals each providing communication between the lumen and an exterior of the stamp.
- 118. (Previously Presented) The method of claim 116, wherein walls defining the first lumen are characterized by flat, curved, or a combination of both.
- 119. (Previously Presented) The method of claim 116, wherein the stamp is tubular.
- 120. (Cancelled).
- 121. (Cancelled).
- 122. (Previously Presented) The method of claim 121, further comprising increasing a cross sectional dimension of the first lumen before the step of disposing the substrate.
- 123. (Currently Amended) The method of claim 116, wherein the substrate comprises a second lumen having a portal providing communication between the second lumen and an exterior of the stamp stamp; and

wherein the step of disposing comprises placing the stamp within the second lumen; and

wherein the step of modulating comprises increasing a cross sectional dimension of the first lumen.

- 124. (Cancelled).
- 125. (Previously Presented) The method of claim 124, further comprising reducing a cross sectional dimension of the first lumen before the step of disposing the substrate.
- 126. (Previously Presented) The method of claim 1 or 116, wherein the stamp is cylindrical.
- 127. (Previously Presented) The method of claim 1 or 116, wherein the stamp is spherical.
- 128. (Previously Presented) The method of claim 1 or 116, wherein the stamp is elliptical.
- 129. (Previously Presented) The method of claim 1 or 116, wherein the stamp is polygonal.
- 130. (Previously Presented) The method of claim 1 or 116, wherein the stamp takes the shape of a spheroid having a variety of diameter lengths.
- 131. (Cancelled).
- 132. (Currently Amended) The method of claim 1 or 116, wherein the stamp is balloon like a structure having one opening.
- 133. (New) The method of claim 1, wherein the surface of the substrate exhibits convexity in at least one dimension, and said convexity does not result from a surface texture or pattern.